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CONFIRMATION NO. 3577

<b>SERIAL NUMBER</b> 10/757,193	<b>FILING OR 371(c) DATE</b> 01/14/2004 <b>RULE</b>	<b>CLASS</b> 430	<b>GROUP ART UNIT</b> 1756	<b>ATTORNEY DOCKET NO.</b> 0553-0394	
<b>APPLICANTS</b> Shunpei Yamazaki, Tokyo, JAPAN; Yasuyuki Arai, Atsugi, JAPAN; Yasuko Watanabe, Atsugi, JAPAN; <i>BR</i>					
<b>** CONTINUING DATA *****</b> <i>none</i>					
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003-009111 01/17/2003 <i>BR</i>					
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 04/16/2004</b>					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and <i>BR</i> Acknowledged Examiner's Signature Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 16	<b>TOTAL CLAIMS</b> 18	<b>INDEPENDENT CLAIMS</b> 6
<b>ADDRESS</b> COOK, ALEX, McFARRON, MANZO, CUMMINGS & MEHLER, LTD. SUITE 2850 200 WEST ADAMS STREET CHICAGO, IL60606					
<b>TITLE</b> Method for manufacturing resist pattern and method for manufacturing semiconductor device					
<b>FILING FEE RECEIVED</b> 1028	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		